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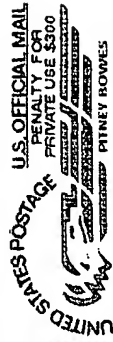
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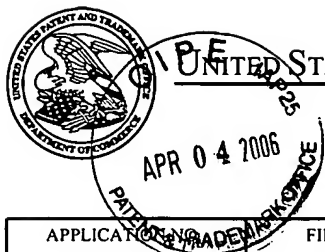
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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/790,939	03/01/2004	Akif Sultan	AMD1:133\HON	2690

23858 7590 03/27/2006

TIMOTHY M HONEYCUTT ATTORNEY AT LAW
P O BOX 1577
CYPRESS, TX 77410

EXAMINER

HOANG, QUOC DINH

ART UNIT	PAPER NUMBER
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2818

DATE MAILED: 03/27/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No. 10/790,939	Applicant(s) SULTAN ET AL.	
	Examiner Quoc D. Hoang	Art Unit 2818	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 01 March 2004.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-21 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☒ Claim(s) 8--13 and 18-21 is/are allowed.
- 6) ☒ Claim(s) 1-7 and 14-17 is/are rejected.
- 7) ☒ Claim(s) 1 is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
 Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
 Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. _____.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).
- * See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|--|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)
2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)
3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date _____ | 4) <input type="checkbox"/> Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____
5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152)
6) <input type="checkbox"/> Other: _____ |
|--|--|

DETAILED ACTION

Information Disclosure Statement

1. The information disclosure statement (IDS) filed on 05/24/2004, 08/02/2004 and 02/05/2005. The references cited on the PTOL 1449 Form have been considered.

Specification

2. The specification has been checked to the extent necessary to determine the present of all possible minor errors. However, Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Claim Objections

3. Claim 1 is objected to because of the following informalities: in claim 1 line 4, "the substrate" should be --a substrate--. Appropriate correction is required.

Claim Rejections - 35 USC § 102

4. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

5. Claims 1 and 3-5 are rejected under 35 U.S.C. 102(e) as being anticipated by Shih., (US Pat No. 6,747,325).

Regarding claim 1, Shih teaches a method of fabricating a first halo region 427 and a second halo region 428 for a circuit device of a first conductivity type and having a gate structure 46 with first and second sidewalls, comprising:

forming the first halo region 427 of a second conductivity type by implanting a substrate 42 with impurities in a first direction A toward the first sidewall of the gate structure 46 (col. 6 lines 1-23 and Fig. 4g);

forming the second halo region 428 of the second conductivity type by implanting the substrate 42 with impurities in a second direction B toward the second sidewall of the gate structure 46 (col. 6 lines 1-23 and Fig. 4h); and

wherein the first and second halo regions are formed without implanting impurities in a direction substantially perpendicular to the first and second directions. *Noted that the first and second halo regions are formed only in A and B implanting directions.*

Regarding claim 3, Shih teaches wherein the first conductivity type comprises n-type and the second conductivity type comprises p-type (col. 6 lines 1-23).

Regarding claim 4, Shih teaches wherein the first direction A is substantially perpendicular to the first sidewall (see Fig. 4g). *Noted that first direction A can be seen substantially perpendicular to the first sidewall from the top view in Fig. 4g.*

Regarding claim 5, Shih teaches wherein the first direction A is substantially perpendicular to the first sidewall and the second direction B is substantially perpendicular to the second sidewall. *Noted that second direction B can be seen substantially perpendicular to the second sidewall from the top view in Fig. 4h.*

Claim Rejections - 35 USC § 103

6. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

7. Claim 2 is rejected under 35 U.S.C. 103(a) as being unpatentable over Shih., (US Pat No. 6,747,325) in view of Cho et al., (US Pat No. 6,784,062 hereinafter "Cho").

Regarding claim 2, Shih teaches wherein the first conductivity type comprises n-type and the second conductivity type comprises p-type (col. 6 lines 1-23), but does not teach wherein the first conductivity type comprises p-type and the second conductivity type comprises n-type.

However, Cho teaches wherein the first conductivity type comprises p-type (p-channel transistor) and the second conductivity type comprises n-type (col. 4, lines 1-6 and Fig. 5, n-type halo region 52). Since Shih and Cho are all from the same field of endeavor, the purpose disclosed by Cho would have been recognized in the pertinent art of Shih. It would have been obvious to a person of ordinary skill in the art at the time of the invention was made to have second conductivity type comprises n-type so that the doping in the channel region and the halo region is the same type.

8. Claims 6 and 7 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shih., (US Pat No. 6,747,325).

Regarding claim 6, Shih teaches wherein the implanting impurities in the first direction A is performed at an angle of about 0 to 30° from vertical (col. 6 line 15), but

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does not teach wherein the implanting impurities in the first direction A is performed at an angle of about 15 to 45° from vertical. Although Shih's implantation in a direction is not the claimed range (15 to 45° from vertical), this does not define patentable over Shih since the implantation direction is well known processing variable and the discovery of the optimum or workable range involves only routine skill in the art.

Regarding claim 7, Shih teaches wherein the implanting impurities in the second direction B is performed at an angle of about 0 to 30° from vertical (col. 6 line 55), but does not teach wherein the implanting impurities in the second direction B is performed at an angle of about 15 to 45° from vertical. Although Shih's implantation in a direction is not the claimed range (15 to 45° from vertical), this does not define patentable over Shih since the implantation direction is well known processing variable and the discovery of the optimum or workable range involves only routine skill in the art.

9. Claim 14-17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Cho et al., (US Pat No. 6,784,062 hereinafter "Cho") in view of Shih., (US Pat No. 6,747,325).

Regarding claim 14, Cho teaches a method of fabricating first and second halo regions for a n-channel transistor having a first gate structure and third and fourth halo regions for a p-channel transistor having a second gate structure, comprising:

masking the p-channel transistor (col. 3, lines 25-35 and Fig. 3);

forming the first halo region 32 extending beneath the first gate structure by implanting impurities in a first direction toward a first sidewall of the first gate structure (col. 3, lines 35-50 and Fig. 3);

forming the second halo region 32 extending beneath the first gate structure by implanting impurities in a second direction substantially opposite to the first direction toward a second sidewall of the first gate structure (col. 3, lines 35-50 and Fig. 3);

unmasking the p-channel transistor and masking the n-channel transistor (col. 3, lines 50-56 and Fig. 4);

forming the third halo region 52 by implanting impurities in the first direction toward a first sidewall of the second gate structure (col. 3, lines 57-65 and Fig. 5);

forming the fourth halo region 52 by implanting impurities in the second direction toward a second sidewall of the second gate structure (col. 3, lines 57-65 and Fig. 5).

Cho teaches implanting impurities from four directions to form halo regions 32/52 (col. 3, line 47), but does not teach wherein the first, second, third and fourth halo regions are formed without implanting impurities in a direction substantially perpendicular to the first and second directions.

However, Shih teaches wherein the halo regions 427/428 are formed without implanting impurities in a direction substantially perpendicular to the first direction A and second direction B (col. 6, lines 1-24 and Figs. 4g-4h). Since Cho and Shih are all from the same field of endeavor, the purpose disclosed by Shih would have been recognized in the pertinent art of Cho. It would have been obvious to a person of ordinary skill in the art at the time of the invention was made to implant impurities in first direction A and second direction B so that the width of the depletion regions interfacing the channel region with the source/drain regions is reduced so as to minimize current leakage and punch through effect as taught by Shih, column 6, lines 18-23.

Regarding claim 15, Cho teaches wherein the implanting of impurities in the first and second directions is performed at an angle of 25° , but does not teach wherein the implanting of impurities in the first and second directions is performed at an angle of about 15 to 45° from vertical. Although S Cho' halo implant at an angle is not the claimed range (15 to 45° from vertical), this does not define patentable over Shih since the halo implant at an angle is well known processing variable and the discovery of the optimum or workable range involves only routine skill in the art.

Regarding claim 16, Cho teaches wherein the impurities of the first and second halo regions 32 comprise boron (col. 3, lines 35-40).

Regarding claim 17, Cho teaches wherein the impurities of the third and fourth halo regions 52 comprise phosphorus (col. 3, line 67).

Allowable Subject Matter

10. Claims 8-13 and 18-21 are allowed.

The following is an examiner's statement of reasons for allowance: None of the references of record teaches or suggest the claim method of fabricating halo regions comprising implanting the substrate in a first and second directions perpendicular to the first axis without implanting impurities in a direction substantially parallel to the first axis, and implanting the substrate in a third and fourth directions perpendicular to the second axis without implanting impurities in a direction substantially parallel to the second axis and among other limitations as claimed in independent claim 8.

The following is an examiner's statement of reasons for allowance: None of the references of record teaches or suggest the claim method of fabricating halo regions

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wherein the first and second halo regions of the first group of n-channel transistors and the first group of p-channel transistors are formed without implanting impurities in a direction substantially perpendicular to the first and second directions, and the third and fourth halo regions of the second group of n-channel transistors and the second group of p-channel transistors are formed without implanting impurities in a direction substantially perpendicular to the third and fourth directions and among other limitations as claimed in independent claim 18.

Conclusion

11. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quoc Hoang whose telephone number is (571) 272-1780. The examiner can normally be reached on Monday-Friday from 8.00 AM to 5.00 PM.

If attempt to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers of the organization where this application or proceeding is assigned are (571) 273-8300 for regular communications and (571) 273-8300 for After Final communications.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should

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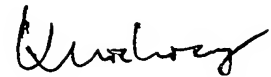
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you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

Quoc Hoang
Patent examiner/AU 2818



03/13/2006



PTO-1449 (modified) 'List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)	ATTY. DOCKET NO. AMDI:133\HON	SERIAL NO. 10/790,939
	APPLICANT Akif Sultan et al.	CERTIFICATE OF MAILING 37 C.F.R. 1.8 I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on the date below: May 21, 2004 Date Timothy M. Honeycutt
	FILING DATE March 1, 2004	GROUP 1

U.S. PATENT DOCUMENTS

EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
m	A1	6,114,211	September 5, 2000	H. Jim Fulford et al.	448	305	
m	A2	5,227,321	July 13, 1993	Ruojia Lee et al.	437	44	
m	A3	10/693,016		Scott Goad et al.			October 24, 2003

FOREIGN PATENT DOCUMENTS

EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION

OTHER ART

EXAM INIT.	REF. DES.	AUTHOR; TITLE; JOURNAL; VOLUME; DATE; PERTINENT PAGES
m	A4	Stanley Wolf and Richard N. Tauber; <i>Silicon Processing for the VLSI Era, Volume 3 - The Submicron MOSFET</i> ; pp.226-232, 240, 309-311 and 621-622; 1995
m	A5	Terence B. Hook et al.; <i>High-Performance Logic and High-Gain Analog CMOS Transistors Formed by a Shadow-Mask Technique With a Single Implant Step</i> ; IEEE Transactions on Electron Devices, Vol. 49, No. 9, September 2002; pp. 1623-1627

EXAMINER	DATE CONSIDERED 03/2006
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement--PTO-1449 (Modified)



Supplemental Form PTO-1449 (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)	ATTY. DOCKET NO. AMDI:133\HON	SERIAL NO. 10/790,939
	APPLICANT Akif Sultan et al.	CERTIFICATE OF MAILING 37 C.F.R. 1.8 I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date below: Date <u>July 29, 2004</u> <u>Timothy M. Honeycutt</u>
	FILING DATE March 1, 2004	GROUP 2812

U.S. PATENT DOCUMENTS

EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
<u> </u>	A1	10/883,925		Edward E. Ehrichs			July 2, 2004

FOREIGN PATENT DOCUMENTS

EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION

OTHER ART

EXAM INIT.	REF. DES.	AUTHOR; TITLE; JOURNAL; VOLUME; DATE; PERTINENT PAGES

EXAMINER <u>Quir Hong</u>	DATE CONSIDERED <u>03/2006</u>
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Information Disclosure Statement-PTO-1449 (Modified)

2nd Supplemental Form PTO-1449 (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)		ATTY. DOCKET NO. AMD1:133\HON		SERIAL NO. 10/790,939			
		APPLICANT Akif Sultan et al.		CERTIFICATE OF FACSIMILE TRANSMISSION 37 C.F.R. § 1.6(d) I hereby certify that this correspondence is being transmitted by facsimile to the Patent and Trademark Office (Fax No. (703) 872-9308), on the date below: Date of transmission <u>February 26, 2005</u> Signature <u>[Signature]</u> Printed Name: <u>Timothy M. Honeycutt</u>			
		FILING DATE March 1, 2004		GROUP 2812			
U.S. PATENT DOCUMENTS							
EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
m	A1	US-5,580,804	12/1996	Joh, Dae Y	438	231	
	A2	US-6,030,871	2/2000	Eitan, Boaz	438	276	
	A3	US-6,620,679	9/2003	Tzeng et al.	438	250	
	A4	US-6,828,202	12/2004	Horch, Andrew	438	302	
✓	A5	US 2003/0032231		Efland et al.	438	200	February 13, 2003
m	A6	US-6,489,223	12/2002	Hook et al.	438	524	
FOREIGN PATENT DOCUMENTS							
EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
OTHER ART							
EXAM INIT.	REF. DES.	AUTHOR; TITLE; JOURNAL; VOLUME; DATE; PERTINENT PAGES					
EXAMINER <u>Quoc Hoang</u>				DATE CONSIDERED <u>03/2006</u>			
<small>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

Information Disclosure Statement-PTO-1449 (Modified)

Notice of References Cited

Application/Control No.

10/790,939

Applicant(s)/Patent Under
Reexamination
SULTAN ET AL.

Examiner

Quoc D. Hoang

Art Unit

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Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,747,325	06-2004	Shih, An	257/408
*	B	US-6,784,062	08-2004	Cho et al.	438/302
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	P					
	Q					
	R					
	S					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.